



# APPLICATION DATA SHEET

Electronic Version 0.0.11

Stylesheet Version: 1.0

Attorney Docket Number: 740756-2722

Publication Filing Type: new-utility

Application Type: utility

Title of Invention: PLASMA TREATMENT APPARATUS

## Legal Representative:

Attorney or Agent: Jeffrey L. Costellia

Registration Number: 35483

Customer Number Correspondence Address: 22204

**\*22204\***

## Foreign Priority:

2003-086384

JP 2003-03-26

Priority Claimed

Assignee (Publish): Semiconductor Energy Laboratory Co., Ltd.

398, Hase,

Atsugi-shi, 243-0036 Kanagawa-ken JP

## INVENTOR(s):

Primary Citizenship: JAPAN

Given Name: Osamu

Family Name: NAKAMURA

Residence City: Atsugi, Kanagawa

Residence Country: JP

Address: c/o Semiconductor Energy Laboratory Co., Ltd.

398, Hase,

Atsugi-shi, Kanagawa-ken, 243-0036 JP